

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Andrew T.H. Lin, Edward W-Y Shih, Richard Yeh

U.S. Serial No: 10/006,066

Group Art Unit: 2834

Filed: 06 December 2001

Examiner: Karl I. Tamal

Title: "METHOD AND SYSTEM FOR SECURING AND CONTROLLING AN ELECTRO-STATICALLY DRIVEN MICRO-MIRROR"

Assistant Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Election Of Claims

Dear Sir:

In response to receipt of a restriction requirement for the patent application identified above, the Applicants herewith cancel claims 15-36 and elect to proceed with prosecution of claims 1-14.

Respectfully Submitted,

Date: 27 October 2003

John Schipper

Patent representative for Applicants



Application No.	Applicant(s)	
10/006,066	LIN ET AL.	
Examiner	Art Unit	ı
Tamai IE Karl	2834	PU

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The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	plication. If not include will be mailed in due	ed course. THIS
1. A This communication is responsive to 2/26/2004.			
2. X The allowed claim(s) is/are 1-8,10,12-14 and 37-44.			
3. The drawings filed on 26 February 2004 are accepted by the	ne Examiner.		
 4. ☐ Acknowledgment is made of a claim for foreign priority un a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application No cuments have been received in this r	V	
Applicant has THREE MONTHS FROM THE "MAILING DATE" on noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the rec	uirements
 A SUBSTITUTE OATH OR DECLARATION must be submi INFORMAL PATENT APPLICATION (PTO-152) which give 			OTICE OF
 6. CORRECTED DRAWINGS (as "replacement sheets") muss (a) including changes required by the Notice of Draftsperson 1) hereto or 2) to Paper No./Mail Date 12/10/0 (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the 	on's Patent Drawing Review (PTO-9 03. Amendment / Comment or in the O 84(c)) should be written on the drawing the header according to 37 CFR 1.121(d	ffice action of gs in the front (not the l).	·
 DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F 	sit of BIOLOGICAL MATERIAL m FOR THE DEPOSIT OF BIOLOGICA	nust be submitted. N NL MATERIAL.	ote the
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Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. Notice of Informal Page	atent Application (PTC)-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Summary		, 102)
3. Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date	Paper No./Mail Date B), 7. ☐ Examiner's Amendm	e ent/Comment	
Examiner's Comment Regarding Requirement for Deposit of Riclogical Material	8. Examiner's Statemen	nt of Reasons for Allo	wance
of Biological Material	9.		
		Tamai IE Karl Primary Examiner Art Unit: 2834	

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Reason for Allowance

1. The following is an examiner's statement of reasons for allowance: the prior art does not teach an electrostatic actuated micromirror having three or more supporting springs at spaced apart locations to provide a restoring force for at least two degrees of freedom of movement for the micromirror. The spring connections being spaced apart to form a conceptual polygon, where the springs maintain a length to thickness ratio to operate the springs in a tensile mode. The electrostatic actuator having three or more spaced apart and independently controlled driving electrodes and the micro mirror having a frame including dielectric material positioned close to at least one edge of the micromirror and positioned between the first material layer which is the mirror layer and a second material layer with contains the springs. The prior art does not teach an electrostatic actuated micromirror having three or more supporting springs at spaced apart locations to provide a restoring force for at least two degrees of freedom of movement for the micromirror. The spring connections being spaced apart to form a conceptual polygon, where the springs maintain a length to thickness ratio to operate the springs in a tensile mode. The electrostatic actuator having three or more spaced apart and independently controlled driving electrodes, with one or more neutral electrodes adjacent the mirror with the same electric potential as the mirror.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Drawings

- 2. The drawings were received on 2/26/2004. These drawings are approved.
- 3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Karl I.E. Tamai whose telephone number is (571) 272 2036.

The examiner can be normally contacted on Monday through Friday from 8:00 am to 4:00 pm. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mr. Darren Schuberg, can be reached at (571) 272 - 2044. The facsimile number for the Group is (703) 872 - 9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Karl I Tamai PRIMARY PATENT EXAMINER April 23, 2004

KARL TAMAI PRIMARY EXAMINER